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Inventor Name Search Result

Your Search was: for SN09/617,254

Last Name = SHINRIKI
First Name = HIROSHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 49
60510059	Not Issued	159	10/09/2003	APPARATUS AND METHOD FOR FORMING A THIN FILM USING HIGH-SPEED VALVE CONTROL	SHINRIKI, HIROSHI
10960600	Not Issued	019	10/07/2004	APPARATUS AND METHOD FOR FORMING THIN FILM USING UPSTREAM AND DOWNSTREAM EXHAUST MECHANISMS	SHINRIKI, HIROSHI
10946511	Not Issued	018	09/20/2004 ND	SUBSTRATE PROCESSING APPARATUS AND SUBSTRATE PROCESSING METHOD, HIGH SPEED ROTARY VALVE, AND CLEANING METHOD	SHINRIKI, HIROSHI
10913531	Not Issued	030	08/09/2004 ND	SINGLE-SUBSTRATE-HEAT-PROCESSING APPARATUS FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SHINRIKI, HIROSHI
10824798	Not Issued	030	04/15/2004 ND	THIN-FILM DEPOSITION APPARATUS	SHINRIKI, HIROSHI
10678045	Not Issued	030	10/03/2003 ND	METHOD OF AND APPARATUS FOR PROCESSING SUBSTRATES	SHINRIKI, HIROSHI
10473205	Not Issued	030	04/09/2004 ND	METHOD AND DEVICE FOR PROCESSING SUBSTRATE, AND APPARATUS FOR MANUFACTURING SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
10457450	Not Issued	071	06/10/2003 ND	FABRICATION PROCESS OF A SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
10380696	Not Issued	030	10/14/2003 ND	METHOD FOR FILM FORMATION OF GATE	SHINRIKI, HIROSHI

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				INSULATOR, APPARATUS FOR FILM FORMATION OF GATE INSULATOR, AND CLUSTER TOOL	
10344281	6806211	150	08/25/2003	DEVICE AND METHOD FOR PROCESSING SUBSTRATE	SHINRIKI, HIROSHI
10333406	Not Issued	041	06/13/2003	METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE, SUBSTRATE TREATER, AND SUBSTRATE TREATMENT SYSTEM	SHINRIKI, HIROSHI
10311880	Not Issued	030	03/12/2003	METHOD FOR FORMING THIN FILM AND APPATUS FOR FORMING THIN FILM	SHINRIKI, HIROSHI
10310949	Not Issued	071	12/06/2002	RADICAL PROCESSING OF A SUB-NANOMETER INSULATION FILM	SHINRIKI, HIROSHI
10239648	Not Issued	092	12/06/2002	METHOD OF FORMING A DIELECTRIC FILM	SHINRIKI, HIROSHI
10133902	Not Issued	061	04/29/2002	THIN FILM FORMING APPARATUS	SHINRIKI, HIROSHI
09830121	6800139	150	07/16/2001	FILM DEPOSITION APPARATUS AND METHOD	SHINRIKI, HIROSHI
09795437	Not Issued	161	03/01/2001	SINGLE-SUBSTRATE-HEAT-PROCESSING APPARATUS AND METHOD FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SHINRIKI, HIROSHI
09658507	6485564	150	11/13/2000	THIN FILM FORMING METHOD	SHINRIKI, HIROSHI
09657627	Not Issued	093	09/08/2000	METHOD OF FORMING A THIN FILM	SHINRIKI, HIROSHI
09641681	6756235	150	08/18/2000	METAL OXIDE FILM FORMATION METHOD AND APPARATUS	SHINRIKI, HIROSHI
09631978	6467491	150	08/03/2000	PROCESSING APPARATUS AND PROCESSING METHOD	SHINRIKI, HIROSHI
09617254	Not Issued	071	07/14/2000	FILM FORMING APPARATUS AND METHOD, AND FILM MODIFYING APPARATUS AND METHOD	SHINRIKI, HIROSHI
09613694	6428850	150	07/10/2000	SINGLE-SUBSTRATE-PROCESSING CVD METHOD OF FORMING FILM	SHINRIKI, HIROSHI

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				CONTAINING METAL ELEMENT	
09598247	6482266	150	06/21/2000	METAL ORGANIC CHEMICAL VAPOR DEPOSITION METHOD AND APPARATUS	SHINRIKI, HIROSHI
09335526	6232248	150	06/18/1999	SINGLE-SUBSTRATE-HEAT-PROCESSING APPARATUS AND METHOD FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SHINRIKI, HIROSHI
09310132	6126753	150	05/12/1999	SINGLE-SUBSTRATE-PROCESSING CVD APPARATUS AND METHOD	SHINRIKI, HIROSHI
09134372	6001729	150	08/14/1998	METHOD OF FORMING WIRING STRUCTURE FOR SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
09081047	6063703	150	05/19/1998	METHOD FOR MAKING METAL INTERCONNECTION	SHINRIKI, HIROSHI
08889590	6143081	150	07/08/1997	FILM FORMING APPARATUS AND METHOD, AND FILM MODIFYING APPARATUS AND METHOD	SHINRIKI, HIROSHI
08791161	5973402	150	01/30/1997	METAL INTERCONNECTION AND METHOD FOR MAKING	SHINRIKI, HIROSHI
08569319	5627102	150	12/08/1995	METHOD FOR MAKING METAL INTERCONNECTON WITH CHLORINE PLASMA ETCH	SHINRIKI, HIROSHI
08518322	5834846	150	08/23/1995	SEMICONDUCTOR DEVICE WITH CONTACT STRUCTURE AND METHOD OF MANUFACTURING THE SAME	SHINRIKI, HIROSHI
08353296	5565702	250	12/05/1994	ANTIFUSE ELEMENT, SEMICONDUCTOR DEVICE HAVING ANTIFUSE ELEMENTS, AND METHOD FOR MANUFACTURING THE SAME	SHINRIKI, HIROSHI
08353294	5641985	150	12/05/1994	ANTIFUSE ELEMENT AND SEMICONDUCTOR DEVICE HAVING ANTIFUSE ELEMENTS	SHINRIKI, HIROSHI
08353287	5679974	150	12/05/1994	ANTIFUSE ELEMENT AND SEMICONDUCTOR DEVICE HAVING ANTIFUSE	SHINRIKI, HIROSHI

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				ELEMENTS	
08274427	Not Issued	161	07/13/1994	METHOD AND APPARATUS FOR FORMING A THIN FILM ON A SEMICONDUCTOR SUBSTRATE	SHINRIKI, HIROSHI
08264928	5652180	150	06/24/1994	METHOD OF MANUFACTURING SEMICONDUCTOR DEVICE WITH CONTACT STRUCTURE	SHINRIKI, HIROSHI
08228257	5521423	150	04/15/1994	DIELECTRIC STRUCTURE FOR ANTI-FUSE PROGRAMMING ELEMENT	SHINRIKI, HIROSHI
08216581	Not Issued	166	03/22/1994	METAL INTERCONNECTION AND METHOD FOR MAKING	SHINRIKI, HIROSHI
07883531	5292673	150	05/15/1992	METHOD OF MANUFACTURING A SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
07846828	5336638	150	03/06/1992	PROCESS FOR MANUFACTURING SEMICONDUCTOR DEVICES	SHINRIKI, HIROSHI
07812836	Not Issued	161	12/20/1991	CAPACITOR AND PRODUCTION METHOD	SHINRIKI, HIROSHI
07561602	Not Issued	161	08/02/1990	METHOD OF MAUFACTURING A SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
07517323	5079191	150	05/01/1990	PROCESS FOR PRODUCING A SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
07469377	Not Issued	166	01/24/1990	CAPACITOR AND PRODUCTION METHOD	SHINRIKI, HIROSHI
07247343	4937650	150	09/21/1988	SEMICONDUCTOR CAPACITOR DEVICE WITH DUAL DIELECTRIC	SHINRIKI, HIROSHI
07081231	4891684	150	08/04/1987	SEMICONDUCTOR DEVICE	SHINRIKI, HIROSHI
06936603	Not Issued	161	12/01/1986	SEMICONDUCTOR DEVICE AND PROCESS FOR PRODUCING THE SAME	SHINRIKI, HIROSHI
06860413	4809052	150	05/07/1986	SEMICONDUCTOR MEMORY DEVICE	SHINRIKI, HIROSHI

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First Name = HIROSHI

Application#	Patent#	Status	Date Filed	Title	Inventor Name 0

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Inventor Name Search Result

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← spelled different on parent

Last Name = SUGIRA
First Name = MASHITO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 1
09617254	Not Issued	071	07/14/2000	FILM FORMING APPARATUS AND METHOD, AND FILM MODIFYING APPARATUS AND METHOD	SUGIRA, MASHITO

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Inventor Name Search Result

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Last Name = SUGIURA
First Name = MASAHITO

Application#	Patent#	Status	Date Filed	Title	Inventor Name 15
10927102	Not Issued	030	08/27/2004	FILM FORMING METHOD AND FILM FORMING APPARATUS	SUGIURA, MASAHITO
10913531	Not Issued	030	08/09/2004	SINGLE-SUBSTRATE-HEAT-PROCESSING APPARATUS FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SUGIURA, MASAHITO
10673908	Not Issued	041	09/30/2003	LOW-PRESSURE DEPOSITION OF METAL LAYERS FROM METAL-CARBONYL PRECURSORS	SUGIURA, MASAHITO
10673648	Not Issued	071	09/30/2003	METHOD OF DEPOSITING METAL LAYERS FROM METAL-CARBONYL PRECURSORS	SUGIURA, MASAHITO
10487989	Not Issued	020	02/27/2004	METHOD AND APPARATUS FOR FORMING FILM	SUGIURA, MASAHITO
10312292	Not Issued	041	09/29/2003	ETCHING METHOD	SUGIURA, MASAHITO
10258475	Not Issued	041	04/21/2003	SEMICONDUCTOR DEVICE HAVING A LOW DIELECTRIC FILM AND FABRICATION PROCESS THEREOF	SUGIURA, MASAHITO
10095025	6800546	150	03/12/2002	FILM FORMING METHOD BY RADIATING A PLASMA ON A SURFACE OF A LOW DIELECTRIC CONSTANT FILM	SUGIURA, MASAHITO
10069274	Not Issued	093	06/11/2002	FABRICATION PROCESS OF A SEMICONDUCTOR DEVICE	SUGIURA, MASAHITO
09795437	Not Issued	161	03/01/2001	SINGLE-SUBSTRATE-HEAT-PROCESSING APPARATUS	SUGIURA, MASAHITO

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				AND METHOD FOR PERFORMING REFORMATION AND CRYSTALLIZATION	
09631978	6467491	150	08/03/2000	PROCESSING APPARATUS AND PROCESSING METHOD	SUGIURA, MASAHITO
09613694	6428850	150	07/10/2000	SINGLE-SUBSTRATE-PROCESSING CVD METHOD OF FORMING FILM CONTAINING METAL ELEMENT	SUGIURA, MASAHITO
09335526	6232248	150	06/18/1999	SINGLE-SUBSTRATE-HEAT-PROCESSING APPARATUS AND METHOD FOR PERFORMING REFORMATION AND CRYSTALLIZATION	SUGIURA , MASAHITO
08889590	6143081	150	07/08/1997	FILM FORMING APPARATUS AND METHOD, AND FILM MODIFYING APPARATUS AND METHOD	SUGIURA , MASAHITO
08687951	5755963	150	07/26/1996	FILTER ELEMENT AND FABRICATION METHOD FOR THE SAME	SUGIURA , MASAHITO

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